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SERIAL NUMBER 09/932,943	FILING DATE 08/21/2001 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. 04329.2622
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APPLICANTS

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** CONTINUING DATA *****

NONE

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** FOREIGN APPLICATIONS *****

JAPAN 2000-249129 08/21/2000

Yeo

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IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 09/20/2001

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 25	INDEPENDENT CLAIMS 4
Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Examiner's Signature		Initials			

ADDRESS

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TITLE

Slurry for chemical mechanical polishing and method of manufacturing semiconductor device

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees
RECEIVED	No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> 1.16 Fees (Filing)
1226	No. _____ for following:	<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
		<input type="checkbox"/> 1.18 Fees (Issue)
		<input type="checkbox"/> Other _____